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SERIAL NUMBER 10/594,458	FILING or 371(c) DATE 09/26/2006 RULE	CLASS 438	GROUP ART UNIT 1792	ATTORNEY DOCKET NO. 129546		
APPLICANTS Hideki Sato, Gunma, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP05/04294 03/11/2005 ** FOREIGN APPLICATIONS ***** JAPAN 2004-095864 03/29/2004 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 05/25/2007						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No Verified and Acknowledged <u>/LAN VINH/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance LV Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 3	TOTAL CLAIMS 8	INDEPENDENT CLAIMS 1
ADDRESS OLIFF & BERRIDGE, PLC P.O. BOX 320850 ALEXANDRIA, VA 22320-4850 UNITED STATES						
TITLE Method For Evaluating Crystal Defects Of Silicon Wafer						
FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			